

Form PTO-1449					Attorney Docket No. <b>062004-1211</b>		Serial No. <i>10/687,507</i> <b>To be assigned</b>	
<b>INFORMATION DISCLOSURE CITATION</b>					Applicant <b>Jokerst, et al.</b>			
<i>(Use several sheets if necessary)</i>								
					Filing Date		Group <b>To be assigned</b>	
<b>U.S. PATENT DOCUMENTS</b>								
Examiner Initials	Item	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
<i>CMW</i>	A	4,403,825	9-13-83	Tangonan, et al.	350	96.11	11-14-80	
	B	4,422,181	12-20-83	Grafton, et al.	455	606	8-26-80	
	C	4,493,113	1-8-85	Forrest, et al.	455	606	9-10-82	
	D	4,611,884	9-16-86	Roberts	350	96.15	11-24-82	
	E	4,705,346	11-10-87	Miyawaki	350	96.14	5-13-85	
	F	4,773,722	9-27-88	Perino	350	96.18	11-22-83	
	G	4,775,971	10-4-88	Bergmann	370	3	3-24-86	
	H	4,890,895	1-2-90	Zavracky, et al.	350	96.20	11-13-87	
	I	5,347,601	9-13-94	Ade, et al.	385	3	3-29-93	
	J	5,357,363	10-18-94	Li, et al.	359	161	6-24-63	
<i>CMW</i>	K	5,400,419	3-21-95	Heinen	385	14	12-3-93	
<b>FOREIGN PATENT DOCUMENTS</b>								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	L							
	M							
	N							
	O							
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)</b>								
<i>CMW</i>	P	Hamilton, et al. "Basic Integrated Circuit Engineering", 1975, Pages 96-99.						
<i>CMW</i>	Q	Vendier, et al. "High Efficiency Thin-Film GaAs-based MSM Photodetectors", Electronics Letters, 15th, February, 1996, Vol. 32, No. 4, Pages 394-395.						
<i>CMW</i>	R	Jokerst, et al. "Thin-Film Multimaterial Optoelectronic Integrated Circuits", IEEE Transactions on Components Packaging & Manufacturing Technology-Part B, Vol. 19, No. 1, February 1996, Pages 97-106.						
* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.								
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U.S. PATENT DOCUMENTS								
Examiner Initials	Item	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
<i>CMN</i>	S	5,424,860	6-13-95	Mihara	359	152	11-9-93	
	T	5,546,212	8-13-96	Kunikane, et al.	359	163	10-18-94	
	U	5,818,984	10-6-98	Ahmad, et al.	385	14	11-18-96	
	V	5,914,976	6-22-99	Jayaraman, et al.	372	50	1-8-97	
	W	6,097,521	8-1-00	Althaus, et al.	359	143	3-30-99	
	X	6,188,495	2-13-01	Inoue, et al.	359	152	11-21-97	
	Y	6,281,999	8-28-01	Watson, et al.	359	152	7-9-98	
	Z	6,301,035	10-9-01	Schairer	359	152	6-25-98	
	aa	6,320,686	11-20-01	Schairer	359	152	6-25-98	
	bb	6,353,491	3-5-02	Tanaka, et al.	359	152	8-20-98	
	cc	6,437,891	8-20-02	Chandrasekhar, et al.	359	152	10-27-98	
	<i>CMN</i>	dd	6,603,584	8-5-03	Jokerst, et al.	359	152	8-26-99

  

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes    No
	ee						
	ff						
	gg						
	hh						

  

OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, etc.)</i>		
<i>CMN</i>	ii	Vendier, et al. "Thin-Film Inverted MSM Photodectors", IEEE Photonics Technology Letters, Vol. 8, No. 2, February, 1996.
<i>CMN</i>	jj	Vendier, et al. "Stacked Silicon CMOS Circuits with a 40-Mb/s Through-Silicon Optical Interconnect", IEEE Photonics Technology Letters, Vol. 10, No. 4, April 1998, Pages 606-608.
	kk	

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